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Highly Selective and Self-Powered Gas Sensor via Organic Surface Functionalization of p-Si/n-ZnO Diodes

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Low power consumption and reliable selectivity are the two main requirements for gas sensors to be applicable in mobile devices.^[1] These technological platforms, e.g. smart phones or wireless sensor platforms will facilitate personalized detection of environmental and health conditions, and hence becoming the basis of the future core technology of ubiquitous sensing. Even today, health control as well as environmental monitoring is relying on immobile and complex detection systems with very limited availability in space and time. Recent works have shown promising concepts to realize self-powered gas sensors that are capable of detecting gases without the need of external power sources to



activate the sensor-gas interaction or to actively generate a read out signal. [2,3] These sensors drastically reduce power consumption compared to conventional semiconductor gas sensors and additionally reduce the required space for integration. All these attempts so far were based on purely nano structured inorganic metal oxide sensor materials that provide a good sensitivity towards different gases due to their high surface-to-volume ratio. However, due to their non-selective sensing mechanism based on oxygen vacancy-gas interactions, these purely inorganic sensors cannot accomplish a meaningful gas selectivity. [4,5] High selectivities towards single gas species have been recently reported via modifying the inorganic surface of nanostructured semiconductors with a defined organic functionality. [6-9] Theoretical simulations based on ab-initio density functional theory (DFT) for a system composed of SnO₂ NWs modified with a defined self assembled monolayer (SAM) elucidated the reason for the high selectivity of such gas sensor: the energetic position of the SAM-gas frontier orbitals with respect to the NW Fermi level have been identified to be the crucial factor to ensure an efficient charge transfer upon gas-SAM binding interactions and thus to sense or discriminate a certain gas species.^[7] The high flexibility of organic surface modifications in terms of functional groups as well as their sterical and electronic structure possibly might enable the targeted design of various specific gas sensors. However, all organic surface modified sensor systems so far are based on compact conductometric or field effect transistor (FET) sensor concepts that still require a remarkable amount of energy to generate a sensor signal (e.g. by applying a source-drain current). Up to date, none of the semiconductor based gas sensor systems could accomplish both, the selfpowered/low powered sensor operation and highly selective gas detection within a single and compact device.

In this work, we present a semiconductor based gas sensor concept that combines the two substantial requirements of mobile gas sensing in a singular sensor device: self-powered operation combined with high gas selectivity. Beyond the combination of self-powered sensing and high selectivity, also a very high sensitivity could also been demonstrated for the exemplified target gas nitrogen dioxide (NO₂). The sensor reported here was capable of detecting NO₂ concentrations in the sub ppm level with a very high selectivity which is a crucial detection region since NO₂ is considered to be one of the major threads for human health and already toxic at very low concentrations (ppb level). [10] NO₂ is released



in urban and industrial environments by various combustion processes and can produce ozone, respiratory ailments^[11] and is suspected to cause cancer.^[12] For all these, the here presented technology could depict an approach for the much sought-after wide spread sensor networks to monitor densely populated areas to improve the ambient air quality.

Figure 1a schematically shows the production process of our self-powered and selective sensor device based on nanostructured p-Si/n-ZnO diodes. After patterning of a p-Si layer on SiO₂ via reactive ion etching (RIE), photolithographic methods were used to deposit layers of 20 nm ZnO selectively on the p-Si sidewalls that served as a seed layer for site selective growth of n-ZnO nanowires to form p-Si/n-ZnO heterojunctions (Figure 1b and c). X-ray diffraction spectra revealed a good crystallinity and a disproportionate peak attributed to the ZnO (002) facet indicated an oriented growth direction along the c-axis (Figure S1). Under illumination with solar light (AM1.5), an open circuit voltage (V_{oc}) is induced by the build-in potential at the p-n heterojunction^[2,13,14] that is used as a self-generated signal for the sensor. To ensure a strong and measurable V_{oc} signal even under low illumination conditions, every device contained several diodes connected in series by evaporated gold contacts (9, 16 or 26 diodes; see Figure 1c). This configuration resulted in a linear increase of the measured V_{oc} signal proportional with the number of diodes in series under light, with an average contribution of $V_{oc,exp}$ = 72 ± 6 mV/diode (typical value for p-Si/n-ZnO diodes)^[2] and leads to measured values of 0.65 V (9 diodes), 1.35 V (16 diodes) and 1.84 V (26 diodes) respectively (see Figure 1c and Figure S2 in supporting information).

Figure 1d shows the band diagram of the Au/p-Si/n-ZnO/Au system in equilibrium (see supporting information for further details). While the band gap of ZnO ($E_{g,ZnO}=3.37eV$) makes it unsuitable for photovoltaic conversion in the visible range, only the Si serves as a photon absorber. By design, the depleted region of the heterojunction (depletion width $X=0.646~\mu m$) mainly extends within the p-Si ($X_{Si}=0.637~\mu m$), according to the impurity concentrations of the here used materials ($N_a=1.355\cdot 10^{15}~cm^{-3}$ for p-Si) and assuming a typical value of $N_d=1\cdot 10^{17}~cm^{-3}$ for n-ZnO produced by this method. Under these conditions, the theoretical V_{oc} in an ideal heterojunction has been estimated to be $V_{oc,theor,ideal}=479~mV/diode$, which relates to the built-in potential formed between the ZnO conduction band and silicon valence band under non-biased conditions (see supporting information).



The discrepancy to our experimentally observed values ($V_{oc,exp} = 72\pm6$ mV/diode) can be explained by a significant current leakage due to defect induced carrier recombination at the p-n interface. This effect is typically found in Si-ZnO junctions owing to the large lattice mismatch^[17,18] and sputter effects during the dry etching process of silicon. In fact, simulations (see Figure S4.a) predict $V_{oc,theor,leakage} = 68$ mV/diode considering a shunt resistances of around 30 Ω cm² to account for these effects (to be compared with values around 1 k Ω cm² for a commercial solar cell).^[19] Furthermore, the band diagram shows that the back contact is not ohmic, as the ZnO bands bend 0.59 eV at the ZnO/Au interface. This limits the forward current of the p-Si/n-ZnO structure but will not substantially affect the V_{oc} , as no current is flowing under open circuit conditions.

For the organic modification of the n-ZnO NWs, two different methoxysilanes were used to form SAMs on the surface of the n-ZnO NWs, owning amine ([3-(2-aminoethylamino)propyl]-trimethoxylsilane 1) and thiole ((3-mercapto-propyl)trimethoxysilane 2) functionalities respectively. The successful immobilization of the amine 1 and thiole 2 terminated SAMs on ZnO NWs was investigated via high resolution Auger spectroscopy (spatial resolution < 20 nm). Characteristic carbon and oxygen signals were detected for both devices. Nitrogen and sulfur signals for the amine and thiole functionalized devices respectively documented the as expected organic surface character of the sensor devices (see Figure S5).

To measure the sensing characteristics of the devices functionalized with amine and thiole SAMs, the respective substrate was placed in a sensing chamber and illuminated through a quartz window to generate the monitored V_{oc} signal. All measurements were performed with samples composed of 16 diodes in series, as they offered the best compromise in terms of signal value and noise level. The test gases were diluted in dry synthetic air (blend of 21% O_2 and 79% N_2) and applied via a mass flow controller system into the sensing chamber. **Figure 2a** shows the response of an amine functionalized sensor towards different concentrations of NO_2 (250, 500, 750 ppb). Although the V_{oc} signal showed a relatively high noise level, a linear increase of the response (ΔV_{oc}) with increasing NO_2 concentration could be observed. The ΔV_{oc} values were calculated as:



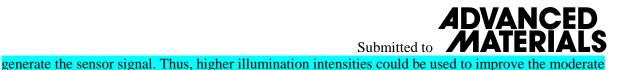
$$\Delta V_{oc}(\%) = \left(\frac{V_{oc,gas}}{V_{oc,air}} - 1\right) \cdot 100 \tag{1}$$

where $V_{oc,gas}$ is the measured sensor signal and $V_{oc,air}$ the baseline value measured in pure synthetic air atmosphere. Even the lowest value of 250 ppb could be detected with a signal response of $\Delta V_{oc} = 7.5\%$ and the V_{oc} increased by 23.5% with the introduction of 750 ppb NO₂ (see Figures 2 and c). For all concentrations, a full signal recovery was observed after switching back to pure synthetic air (typical recovery times were about 5 minutes). The results proof that the device is capable of detecting NO₂ in self-powered operation at low ppb values, which is the above mentioned critical range for environmental monitoring.^[10] From the observed linear sensing characteristic of the amine functionalized sensor, the detection limit for NO_2 can be approximated as $[NO_2]_{min} = 170$ ppb with a signal to noise ratio of 2. In sharp contrast to the amine modified device, the response of the thiole modified device was observed to be negative. An even higher absolute response of $\Delta V_{oc} = -9.8\%$ towards 250 ppb of NO2 was achieved for this device. In any case, the increase of sensor response for the thiole modified samples did not proceed linear with the NO₂ concentrations and reached a saturation value of $\Delta V_{oc} = -12.8\%$ for 500 and 750 ppb. This characteristic is suitable for highly sensitive NO₂ detection, while a quantitative sensing could not be realized at concentrations >250 ppb by using the thiole SAM. Remarkably, the inverted sensor signals for the two different organic functionalities prove that the critical gas-surface interactions of the sensor device and consequent electrical modulations are guided by the nature of the SAM molecules. The fact that no response towards NO₂ was observed for devices without SAM modification further indicates that the gas-sensor interaction is solely subsiding by gas-SAM interactions in case of modified samples (see Figure S6), as the incident light (out of the UV range) is not activating direct interaction between ZnO and the surrounding gas atmosphere. [2] Since the illumination with light in the visible range (e.g. natural sunlight) is sufficient to facilitate gas desorption processes for fast response and recovery processes of SAM modified gas sensors,^[7] the organic groups furthermore ensure a sensing operation without the need of external thermal or UV-light energy that is usually required for the activation of the inorganic



surface of traditional gas sensor systems and consume a major fraction of the total required energy in conventional sensor systems.

In order to assess the selective sensing capabilities of our devices, we compared the response towards NO₂ to common interfering and combustion gases (SO₂, NH₃ and CO) of significantly higher concentrations (2.5 - 25 ppm). Figures 3a and b display that the response of the amine functionalized sensor towards all referenced gases is significantly lower than in case of presence of low NO₂ concentrations. For 2.5 ppm of SO_2 , a measurable response of $\Delta V_{oc} = 5.0\%$ was observed. The response per ppm of 2.0 %/ppm was remarkably lower than it was observed for NO₂ (31.3 %/ppm). The response of the amine terminated sensor towards 25 ppm of NH₃ and CO were just above the noise level with $\Delta V_{oc} = 1\%$ (0.04 %/ppm). The same measurements for the thiole modified sensor revealed a relatively low negative response of $\Delta V_{oc} = -3.4\%$ towards 2.5 ppm of SO₂ (-1.35 %/ppm) and an increase of the measured V_{oc} by 4.5%, when 25 ppm of NH₃ were introduced (0.18 %/ppm) (see Figures 4b, c, and Figure S7). No signal change was observed after the introduction of 25 ppm CO. The high response towards low concentrations of NO₂ (-39 %/ppm for 250 ppb; -17.1 %/ppm for 750 ppb) and a lower signal noise qualifies the thiole modified sensor to be suitable for the selective detection of tiny NO₂ concentrations. Nevertheless, the quantitative sensing ability and a higher response at concentrations above 500 ppb, combined with a very high discrimination of other interfering gas species qualifies the amine functionalized sensor to be more adaptive in real applications. Besides these promising findings, the stability of the SAM functionalized sensors is still challenging. After exposing the sensors to sequential pulses of NO₂ for about 8 hours under constant illumination, the sensing response was found to be lowered to about 80% of the initial values. This effect could be attributed to photcatalytic cleavage caused by UV-induced charge transfer from the covalently bound semiconductor substrate or direct UV-induced degradation of the organic SAM. [20] Therefore, our ongoing investigations are focusing on the understanding of such degradation processes as well as their suppression via less harmful operation conditions, e.g. by restricting the incident light spectrum to the visible spectrum. Such illumination energy would be sufficient to facilitate the adsorption/desorption processes of the sensor and still could be absorbed by the p-Si/n-ZnO junction to



dynamic performance of the sensors, just following the strategy observed in a previous work^[7].

In order to better understand the SAM-gas binding interactions and to evaluate variations of the sensing characteristics between amine and thiole terminated species, theoretical DFT calculations were performed. In order to determine the most stable binding geometries of NO_2 for both the amine and thiole groups 115 different SAM- NO_2 configurations with random initial positions and orientations of the NO_2 molecule were relaxed (**Figure S8**). The thus obtained most stable binding geometries of NO_2 with the amine and thiole SAMs respectively are illustrated in **Figure 4a**. For the amine SAM, NO_2 preferably adsorbs near the secondary amine group, where the highest occupied molecular orbital (HOMO) of the SAM is located. For the most stable amine- NO_2 geometry the binding energy E_B amounts to -0.44 eV and a considerably high covalent character of the NO_2 -SAM binding was observed. Here, more negative values of E_B mean stronger binding.

In case of the thiole SAMs the thiole- NO_2 binding energy is found to be considerably weaker ($E_B = -0.22 \text{ eV}$). For the most stable geometry NO_2 adsorbs near the sulfur atom, where the HOMO of the thiole SAM is located, and additionally forms a weak hydrogen bond with one of the OH groups (Figure 4a). For the thiole- NO_2 system some degree of hybridization of the SAM and gas frontier orbitals was also observed and indicated a considerable covalent binding character (Figure S8b). However, here dispersion forces play a more dominant role as compared to the amine case, hence the portion of covalent binding interaction is lower compared to the amine- NO_2 system (see supporting information for further explanation).

Based on these SAM-NO₂ binding geometries, we investigated the positions of the energy levels of the SAM and the most stable SAM-NO₂ systems to get an idea about the change of the electronic structure of the functional groups due to gas adsorption and the differences between the thiole and amine system with respect to the affinity to transfer charges between the SAM-gas system and the ZnO NW. Since the bonding of the amine and the thiole SAM to the ZnO NW in each case occurs most likely via the silicon atom which in both cases has the same chemical environment locally, we chose the average electrostatic potential in the core region of the Si atom of each SAM as common energy reference. Interestingly, we found that NO₂ adsorption leads to a downward shift of the HOMO by 0.52 eV in the



thiole case and, in sharp contrast, an upward shift of 0.13 eV in the amine case (**Figure 4b**). For both systems the LUMO level of the SAM-gas system is much lower than in the NO₂ free case. This low LUMO level is mainly derived from the NO₂ LUMO. The DFT calculations thus show that the electronic structure of the SAM-NO₂ system indeed depends on the specific choice of the SAM and is strongly altered by the NO₂ adsorption (shift of the HOMO and LUMO energies). Moreover, the relatively low position of the thiole-NO₂ LUMO (high electron affinity (EA) of the system) and the relatively high position of the amine-NO₂ HOMO (low ionization potential (IP) of the system) indicate a rather electron acceptor character for the thiole-NO₂ system and a rather electron donor character for the amine-NO₂ system^[21,22]. This is consistent with the experimentally observed reversed signals of V_{∞} of the thiole and amine functionalized NWs. This relative change of the electron donor and acceptor character of the organic functionalities upon NO₂ binding (change of HOMO and LUMO energies) could directly influence the electronic structure of the SAM/n-ZnO system and thus, macroscopically result in a change of the sensor signal (ΔV_{∞}). However, further studies are needed to better understand the mechanism of the consequent interactions at the SAM-NW interface and the consequent change within the electronic n-ZnO structure.

In conclusion, we demonstrated a selective and self-powered gas sensor, capable of detecting low NO_2 concentrations in the ppb range without the need of an external power source. The sensor signal (V_{oc}) was generated by micro-fabricated p-Si/n-ZnO diodes upon visible light illumination. The selective sensing qualities were introduced by functionalization of the n-ZnO surface with amine as well as thiole terminated organic SAMs. Furthermore, the use of an organic SAM facilitated the gas-surface interaction without the need of heat or UV activation, as it is required for bare inorganic gas sensors. Detailed DFT simulations of the SAM-NO₂ binding interactions and subsequent changes of the organic surface group frontier molecular orbitals indicated that the nature of the chemical SAM structure directly determines the gas response of the hybrid material. The contrary relative changes of the ionization potential (IP) and electron affinity (EA) upon NO₂ binding for amine and thiole terminated SAMs correlate well with the experimentally observed sensing results. Therefore, this work gives an insight into the complex sensing mechanism of inorganic-organic hybrid gas sensors and



shows the feasibility of transferring chemical signals from specific organic-gas interaction into active electronic signals solely driven by visible light.

Experimental Section

Preparation of serial p-Si/n-ZnO diodes: The p-Si stripes on SiO₂ where prepared by photolithographic patterning of a SOI wafer (Boron doped, $R = 1-20 \ \Omega cm$) and subsequential reactive etching (RIE) using a mixture of SF₆/O₂ (129/9 sccm) as process gas ($T = -95^{\circ}C$, p = 1.5Pa). For the site selective growth of ZnO NWs, the etched substrate was again photo lithographically patterned and a 20 nm Zn film was deposited via DC sputtering (99.9999% Zn target, Ar), followed by a resign lift-off an annealing at 300°C in air to form a ZnO seed layer. ZnO NWs were grown by immersing the seeded substrate into a 1:1 solution of zinc nitrate ($Zn(NO_3)_2 \cdot 6H_2O$; c = 0.025mol/L) and hexamethylenetetramine (c = 0.025mol/L) and stir the solution for 3h at 90°C. After refreshing the solution, the substrate was stirred for another 3h at 90°C. Subsequently, the substrate was removed from the solution, sonicated for 5 s and rinsed for 30 s in deionized water. The Gold contacts were evaporated using photolithographic methods to connect the fabricated single diodes in series.

Preparation of SAM functionalized p-Si/n-ZnO sensors: The as-prepared p-Si/n-ZnO substrates were cleaned in oxygen plasma for 1 min to remove surface contaminations and provide oxygen groups on the surface for the condensation reaction. Subsequently, the sample was immersed in a 1% ethanol solution of [3-(2-Aminoethylamino)propyl]trimethoxylsilane 1(ABCR GmbH) or (3-Mercaptopropyl)trimethoxysilane 2 (Sigma Aldrich), and was stirred for 3 h. After removal, the sample was subsequently rinsed with ethanol and dried in a vacuum oven for 1 h at 60°C.

Gas sensing experiments: The SAM functionalized p-Si/n-ZnO sensors were electrically contacted via wire bonding and placed in a gas chamber with gas in-, outlet and a quartz window for external illumination. The gas flow was controlled by a flow control system (Gometrics MGP-2) and the V_{oc} sensor signal was monitored by a SMU (Keithley 2400 SourceMeter) that was controlled by self-programmed LabVIEW software (National Instruments Inc.). A Newport Oriel Sol1A 94021A solar simulator (150 W Xenon arc lamp; AM1.5 spectrum) was used for the illumination of sensor devices through a quartz window of the sensing chamber. Light intensities were measured with a calibrated reference cell (Newport). I/V characteristics of the sensor were performed with illumination intensities of 100 mWcm⁻² and gas sensing experiments with an intensity of 30 mWcm⁻². All gas sensing experiments were performed at room temperature.



DFT simulations: All calculations were performed within the PBE framework with the Vienna abinitio Simulation Package (VASP). [23] Here, we used the PAW method and pseudopotentials [24,25] an energy cutoff of 400 eV and Gaussian smearing with a width of 0.1 eV. For relaxations a force cutoff of 0.01 eV/Å was used. Dispersion forces were taken into account by using the semi-empirical DFT-D2 method of Grimme [26] as implemented in VASP. The geometries of the amine and thiole functionalities have been relaxed in simulation boxes of the size 13x13x20 Å³. For the evaluation of the electronic structure properties such as the energy level positions static calculations in simulation boxes with the dimensions 30x30x30 Å³ were used in order to suppress spurious interactions between neighbouring images. The projection of the HOMO of the SAM-NO₂ system onto the molecular subsystems was performed by a preceding projection onto spherical harmonics centered around the corresponding atoms of the subsystems and the subsequent summation of all contributions.

Supporting Information

Supporting Information is available online from the Wiley Online Library or from the author.

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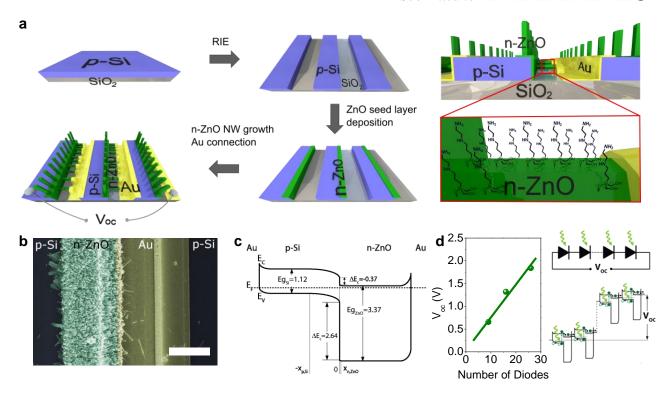


Figure 1. (a) Schematic description of the device fabrication. Higher magnification of a singular p-n unit composed of p-Si μ -trenches. In a subsequent step the n-ZnO nanowires surface was modified by adding a SAM of functional groups. (b) Scanning electron microscope (SEM) image of a singular p-Si/n-ZnO diode (scale bar: 10 μm). (c) Equilibrium band diagram of a single p-Si/n-ZnO diode including the Au contacts on both terminals (see Figure S3 for more details). d) Linear behaviour of the measured V_{oc} with increasing number of diodes under illuminated conditions (simulated sunlight; AM1.5). This is due to the series association of the photodiodes. Upon absorption of light in the depleted region of each one of them, electrons (solid green circles) drift to the n-ZnO part while holes are extracted though the p-Si (open green circles).

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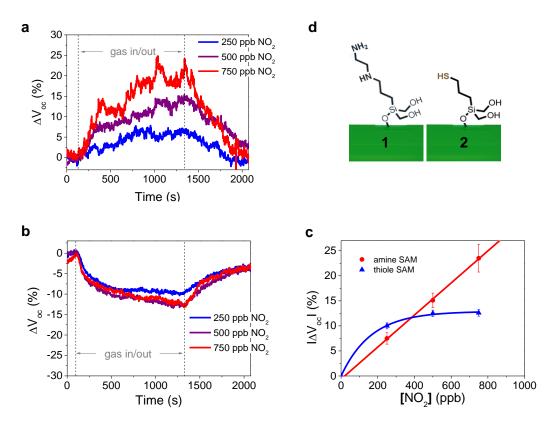


Figure 2. Response of the sensors in a self powered operation towards different concentrations of NO_2 with a) amine and b) thiole terminated SAM functionalizations. c) Diagram of the ΔV_{oc} response versus different NO_2 concentrations for amine and thiole functionalized devices. d) Molecular structure of the amine ([3-(2-aminoethylamino)- propyl]trimethoxylsilane 1) and thiole ((3-mercapto-propyl)trimethoxysilane 2) terminated SAMs.

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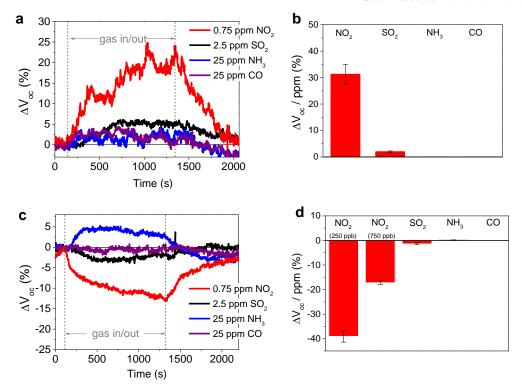


Figure 3. a) Responses of the amine functionalized sensor towards NO₂ in comparison to interfering species (SO₂, NH₃, CO) and b) summary of the sensitivity values. c) Comparative responses of the thiole functionalized sensor and d) summary of the sensitivity values.

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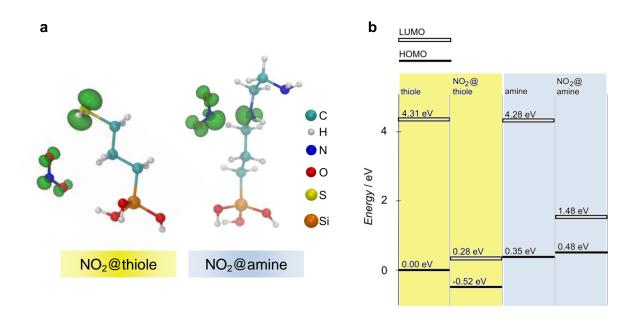


Figure 4. a) Most stable geometries of a NO_2 molecule adsorbed at the thiole and amine functionality respectively. The charge densities of the HOMO wave functions are shown as green isosurfaces. The isosurfaces are drawn at a value of 0.075 e/Å 3 . In both cases the HOMOs are hybrids of the HOMO of the organic functionality and the NO_2 LUMO. In the amine case strong mixing between the amine HOMO and the NO_2 LUMO occurs whereas in the thiole case the HOMO of the combined system is dominated by the thiole HOMO. b) Energy levels of the HOMO and LUMO of the functionalities without adsorbed NO_2 and with adsorbed NO_2 . The averaged electrostatic potential from the core region of the Si atom of each functionality was used as reference potential. The HOMO level of the isolated thiole functionality was set to 0 for convenience.

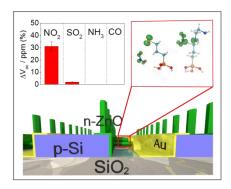


Selectivity and low power consumption are major challenges in the development of sophisticated gas sensor devices. In this work we present a sensor system that unifies selective gas-sensor interactions and energy harvesting properties, using defined organic-inorganic hybrid materials. Simulations of chemical binding interactions and the consequent electronic surface modulation give more insight into the complex sensing mechanism of selective gas detection.

Sensors/Biosensors

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Highly Selective and Self Powered Gas Sensor Enabled via Organic Surface Functionalization of p-Si/n-ZnO Diodes





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Supporting Information

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Highly Selective and Self Powered Gas Sensor Enabled via Organic Surface Functionalization of p-Si/n-ZnO Nanowire Diodes

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A. Crystallographic analysis of n-ZnO NWs grown on p-Si substrate

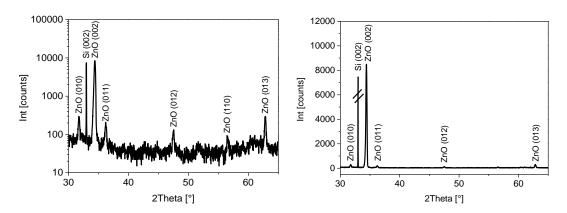


Figure S1. a) Logarithmic and b) linear plot of the XRD spectrum from ZnO NWs, showing the characteristic reflections of hexagonal ZnO, and of the prominent ZnO (002) reflectance that is indicating an aligned growth along the c-axis, respectively



B. Electrical characterization of sensor devices

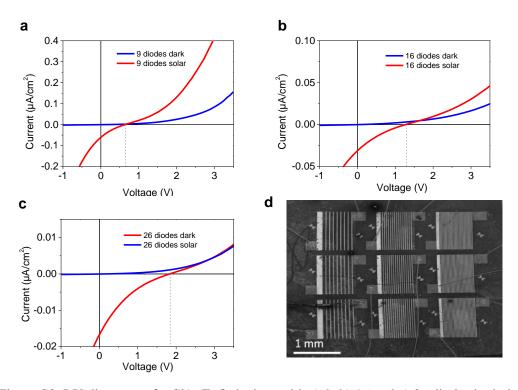


Figure S2. I-V diagrams of p-Si/n-ZnO devices with a) 9, b) 16 and c) 26 diodes in dark conditions (blue) and under solar illumination (AM1.5). The dotted line depicts the V_{oc} values at I=0 A. d) SEM image of a sensor chip with devices of 9, 16 and 26 diodes.



C. Equilibrium band diagram of the heterojunction structure

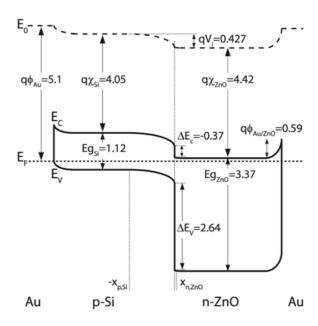


Figure S3. Detailed band diagram of one single p-Si/n-ZnO heterojunction including the two Au metal contacts.

The discontinuity of the conduction (ΔE_c) and valence (ΔE_v) equation (1) and (2)-, the build in potential (V_{bi}) -equation (2)-, the depletion width in the p- (X_{Si}) and n-region (X_{ZnO}) -equations (4) and (5)-, and the bending of the energy bands ($\Delta \phi_{Si}$ and $\Delta \phi_{,ZnO}$) -equations (6) and (7)- [1], where calculated using the values shown in Table S1 for the impurity concentrations of the p- (N_a) and n-type (N_d) materials, the intrinsic carrier concentration (n_i), the work function (ϕ), the electron affinity (χ), the band gap (E_g), the equivalent density of states of the conduction band minimum (N_c) and valence band maximum (N_v), and the dielectric constant (ε) of each material.

$$\Delta E_{c} = q(\chi_{Si} - \chi_{Zn0}) = -0.37eV$$

$$(1)$$

$$\Delta E_{v} = (E_{g,Zn0} - E_{g,Si}) - q(\chi_{Si} - \chi_{Zn0}) = 2.64eV$$
(2)

$$qV_{bi} = q(\phi_{Si} - \phi_{Si}) = (q\chi_{Si} + (E_f - E_v)) - (q\chi_{ZnO} + (E_c - E_f)) = 0.427eV$$
(3)

$$-X_{Si} = \sqrt{\frac{2\varepsilon_{Si}\varepsilon_{Zn0}V_{bi}}{q(N_d\varepsilon_{Zn0} + \varepsilon_{Si}N_a)} \frac{N_d}{N_a}} = -0.637 \mu m$$
(4)

$$X_{Zn0} = \sqrt{\frac{2\varepsilon_{Si}\varepsilon_{Zn0}V_{bi}}{q(N_{d}\varepsilon_{Zn0} + \varepsilon_{Si}N_{a})} \frac{N_{a}}{N_{d}}} = 0.009 \mu m$$
(5)



$$q\Delta\phi_{Si} = q(\phi|_{0} - \phi|_{-x_{Si}}) = \frac{qN_{a}}{2\varepsilon_{Si}}X_{Si}^{2} = 0.419eV$$
(6)

$$q\Delta\phi_{zn0} = q(\phi|_{x_{zn0}} - \phi|_{0}) = \frac{qN_{d}}{2\varepsilon_{zn0}}X_{zn0}^{2} = 0.008eV$$
(7)

Table S1. Electron structure properties of p-Si and n-ZnO.

	Si	ZnO
N_x (cm ⁻³)	$1.35 \cdot 10^{15}$	$1.0 \cdot 10^{17}[2]$
n_i (cm ⁻³)	$1.45 \cdot 10^{10}$ [1]	$4.00 \cdot 10^{-11}$ [1]
qφ (eV)	4.939 [1]	4.424 [2,3]
qχ (eV)	4.05 [1]	4.42 [3]
$\mathbf{E_{g}}\left(\mathbf{eV}\right)$	1.12 [1]	3.37 [4]
$N_c(cm^{-3})$	$2.8 \cdot 10^{19} [1]$	$3.7 \cdot 10^{18} [5]$
$N_v(cm^{-3})$	$1.0 \cdot 10^{19}[1]$	$7.2 \cdot 10^{17}$ [6]
8	11.9 [1]	8.656 [7]

The band bending of ZnO at the ZnO/Au interface was calculated using equation (8), where $q\phi_{Au} = 5.1 \text{ eV}$ [8] and $q\phi_{ZnO} = 4.424 \text{ eV}$ (see Table S1) are the work function of gold and ZnO, respectively:

$$q\Delta\phi_{zn0}\big|_{Au} = q(\phi_{Au} - \phi_{zn0}) = 0.59eV \tag{8}$$



D. Simulation of the optoelectronic device response

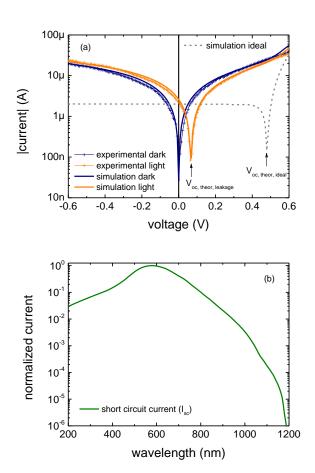


Figure S4. (a) Simulated and experimental I/V diagrams of a p-Si/n-ZnO heterojunction with and without illumination considering interface leakage. For reference, the predicted I/V curve for an ideal p-Si/n-ZnO heterojunction is also given. (b) Simulated spectral response of the p-Si/n-ZnO heterojunctions represented as the normalized short circuit current as a function of the incident photon wavelength.

The electrical behavior of one single p-Si/n-ZnO hereojunction was simulated with PC1D (v5.9), one of the most widely used semiconductor simulators for modeling crystalline solar cells [9].

Our devices were modelled as 1D structures of 10 μ m and 2.2 μ m in length for the Si and ZnO parts and a cross section of 7000 μ m², in accordance with the real geometry. Each semiconductor was described by the values given in Table S1. As for the illumination, an AM1.5g source with 100 mW/cm² of intensity was selected.

The simulations of the band structure in equilibrium lead to results fully consistent with the band diagram shown in Figure S3.



First, the I-V characteristic of an ideal heterojunction was calculated, showing remarkable differences with the experimental data. Specifically, a theoretical open circuit voltage in ideal conditions of $V_{\text{oc,theor,ideal}} = 479 \text{ mV/diode was obtained, in big contrast with the experiments} \\ (V_{\text{oc,exp}} = 72\pm6 \text{ mV/diode}) \text{ (see Figure S4.a)}.$

Then, non-ideal effects were included to obtain a more realistic picture of the device performance. In order to account for the leakage current at the p-n interface, attributed to a significant amount of defect induced carrier recombination [10,11], a shunt resistor in parallel with the structure was considered [12]. Such model successfully predicts the experimental data, with and without illumination, for shunt resistance values of $30~\Omega/\text{cm}^2$. In these conditions, the shape of the I-V curve at low voltages is more linear and the open circuit voltage is reduced down to $V_{\text{oc,theor,leakage}} = 68~\text{mV/diode}$, in accordance with the experimental estimations.

Finally, the spectral response of the device was also modelled, taking into account the light absorption properties of both materials [4]. Figure S4.b shows the spectral response of the device as the normalized short circuit current at wavelengths ranging from 200 to 1200 nm. This result proves that the structure is suitable for operating in the visible range. In fact, additional calculations of the photogeneration rates along the 1D device axis show that visible photons are collected to generate electron-hole pairs only in the Si region, as expected from its bandgap ($E_{g,Si} = 1.12 \text{ eV}$ [1]).



E. Analysis of the organic surface functionalities

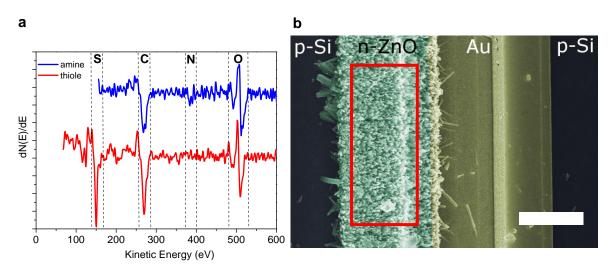


Figure S5. a) Auger spectra for amine and thiole modified ZnO NWs showing nitrogen and sulphur signals respectively as well as carbon and oxygen signals for both samples. b) SEM image of a p-Si/n-ZnO device with depicted measurement area on ZnO NWs. (scale bar: $5 \mu m$)



F. Sensing tests for unmodified sensor devices Supplementary data on sensing experiments

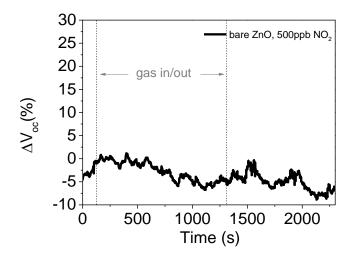


Figure S6. Monitored V_{oc} signal of an unmodified sensor device during a pulse of 500 ppb NO_2

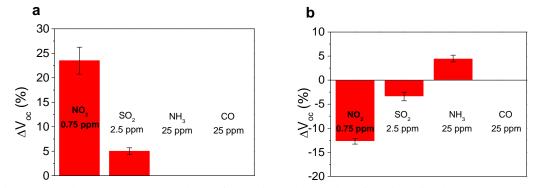


Figure S8. Absolute response values of a) amine and b) thiole functionalized sensors towards NO_2 , SO_2 , NH_3 and CO.



Table S1: Summary of sensitive and selective properties for different state of the art NO₂ sensors in comparison to the sensing device (amine terminated) of this work.

material	NO ₂ conc. (ppb)	S (%)*	S /ppm (%)	selective	Self- powered	source
This work	250-750	7.5	30	yes	yes	
SAM-SnO ₂ NWs**	250-750	850	3400	yes	no	[13]
mod. graphene	1,000-30,000	25	25	yes	no	[14]
PANI-PEO/PVP	125-1,000	<2	<12	moderate	no	[15]
mod. graphene	200,000	25	<<1	no	no	[16]
In ₂ O ₃ NWs	5-1,000	2	400	no	no	[17]
SnO ₂ NW	500	1	<1	no	no	[18]
WO ₃ /MWCNT	500	2.2	<1	no	no	[19]
Si NWs	20-20,000	10	500	no	no	[20]

^{*} absolute sensitivity; related to the lowest given NO₂ concentration in the particular source

^{**} recent work presented by our group



G. Simulation of SAM-gas binding energies and respective HOMO projections

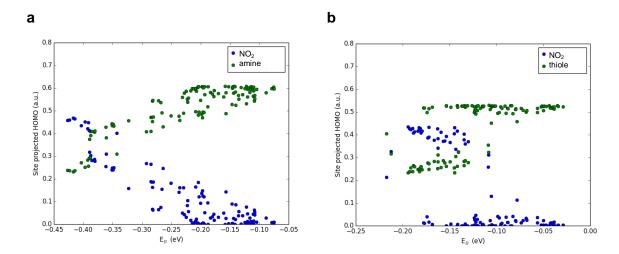


Figure S8. Projection of the HOMO of the SAM-NO₂ system onto the NO₂ molecule and the SAM molecules versus the binding energy for all 115 relaxed investigated SAM-NO₂ systems. a) The hybridization of the HOMO of the amine-NO₂ system strongly correlates with the binding energy. This means that for geometries with strong amine-NO₂ binding the HOMO extents over both subsystems. With decreasing binding strength the HOMO more and more completely localizes on the amine. b) Also for the thiole-NO₂ system we find that hybridization can occur, as the HOMO extents over the NO₂ and the thiole molecule for the strongest binding energies. However, also relatively stable configurations do not necessarily show strong hybridization and a localization of the HOMO is found to be majorly on the thiole (dispersive forces are predominant). The covalent character of the thiole-NO₂ binding interaction, thus, is less dominant than in the amine-NO₂ system.

For the most stable of the considered geometries of the NO_2 -amine system the site projected HOMO indicates a considerable hybridization of the amine HOMO and the lowest occupied molecular orbital (LUMO) of the NO_2 when forming the HOMO and LUMO of the combined SAM- NO_2 system (Figure S8a). Figure 4a shows the charge density associated with the HOMO of the most stable amine- NO_2 system that extends over the LUMO of the NO_2 molecule and the HOMO of the amine functionality. From the strong correlation between this hybridization of amine and NO_2 frontier orbitals and the binding energy of the different relaxed amine- NO_2 geometries we conclude that the amine- NO_2 binding has a considerable covalent character. Yet, if dispersive interaction forces are neglected, $|E_B|$ is only reduced from 0.44 eV to 0.29 eV for the most stable configuration.

In case of the thiole SAMs the thiole- NO_2 binding energy is found to be considerably weaker ($E_B = -0.22$ eV). For the most stable geometry NO_2 adsorbs near the sulfur atom, where the HOMO of the thiole SAM is located, and additionally forms a weak hydrogen bond with one of the OH groups,

Figure 4a. In the thiole case also some degree of hybridization of the SAM and gas frontier orbitals is observed (Figure S8b). However, here the correlation between binding energy and hybridization is less strict than in the amine case. Dispersion forces play a more dominant role here compared to the amine case. Disregarding dispersion forces $|E_B|$ is reduced from 0.22 eV to 0.12 eV for the most stable thiole-



 NO_2 geometry, thus, the portion of covalent binding interaction is lower compared to the amine- NO_2 system.

In the thiole case also some degree of hybridization of the SAM and gas frontier orbitals is observed (Figure S8b). However, here the correlation between binding energy and hybridization is less strict than in the amine case. Dispersion forces play a more dominant role here compared to the amine case. Disregarding dispersion forces $|E_B|$ is reduced from 0.22 eV to 0.12 eV for the most stable thiole-NO₂ geometry, thus, the portion of covalent binding interaction is lower compared to the amine-NO₂ system.



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